



Attorney Docket No. 0756-7223

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ENTERED
BY RCE
10/30/06
RCE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/721,075

Filed: November 26, 2003

For: LASER IRRADIATION APPARATUS,

LASER IRRADIATION METHOD,

AND METHOD FOR

MANUFACTURING A

SEMICONDUCTOR DEVICE

) Group Art Unit: 1725

) Examiner: Maria A. Elve

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
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) Commissioner for Patents, P.O. Box 1450,
) Alexandria, VA 22313-1450, on September
) 28, 2006.

) Ashley M. Stamps

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated June 28, 2006, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 3 of this paper.